

Haruo Sudo

List of Publications by Year in descending order

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4
papers

24
citations

2258059

3
h-index

2272923

4
g-index

4
all docs

4
docs citations

4
times ranked

24
citing authors

#	ARTICLE	IF	CITATIONS
1	Impact of Rapid Thermal Oxidation at Ultrahigh-Temperatures on Oxygen Precipitation Behavior in Czochralski-Silicon Crystals. ECS Journal of Solid State Science and Technology, 2013, 2, P66-P70.	1.8	12
2	Control of grown-in defects and oxygen precipitates in silicon wafers with DZ-IG structure by ultrahigh-temperature rapid thermal oxidation. Journal of Applied Physics, 2018, 123, 161591.	2.5	6
3	Point Defect Reaction in Silicon Wafers by Rapid Thermal Processing at More Than 1300°C Using an Oxidation Ambient. ECS Journal of Solid State Science and Technology, 2019, 8, P35-P40.	1.8	5
4	Formation behavior of oxygen precipitates in silicon wafers subjected to ultra-high-temperature rapid thermal process. Journal of Applied Physics, 2022, 131, 055704.	2.5	1